UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO. : 7,033,717 B2
APPLICATION NO. : 10/630772
DATED : April 25, 2006
INVENTOR(S) : Satoshi Kojima et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

COLUMN 2:
Line 46, "come" should read --become--.

COLUMN 3:
Line 40, "remains" should read --remain--.
Line 44, "are" should read --is--.
Line 60, "come" should read --become--.

COLUMN 6:
Line 27, "come" should read --become--.

COLUMN 9:
Line 39, "that" should read --so that--.

COLUMN 13:
Line 43, "is" should read --are--.
Line 44, "SiF4" should read --SiF_4--.

COLUMN 14:
Line 17, "$P2H_4$" should read --P_2H_4--.

COLUMN 19:
Line 45, "comes" should read --becomes--.

COLUMN 20:
Line 40, "aimed" should read --aimed for--.
Line 51, "any" should read --for any--.

COLUMN 22:
Line 8, "optionally incorporated with" should read --optionally incorporate--.

COLUMN 24:
Line 26, "once" should read --first--.

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COLUMN 43:
Line 34, "Example," should read:
--Example, photosensitive members A-10A to A-l0F were produced in which their upper-part blocking layers were so formed as to be different in layer thickness by changing film formation time.

Table A-24

	Upper-part blocking layer	Surface layer
Source gas and flow rate:		
SiH_4 [ml/min(normal)]	70	30
B_2H_6 (ppm) (based on SiH_4)	10,000	-
CH_4 [ml/min(normal)]	490	400
Substrate temperature:		
(°C)	280	280
Reactor internal pressure:		
(Pa)	80	80
High-frequency power:		
(W)	300	100
Layer thickness:		
(μm)	0.003 to 1.5	0.5

The negative-charging photosensitive members obtained following the above procedure were evaluated in the same manner as in Example A-l, on the size of the spherical protuberances was further evaluated. The surface of the first layer seen through the surface layer and upper-part blocking layer was observed with an optical microscope to examine the diameter of the largest spherical protuberance. As the result, it was found that, under the production conditions of this Example, the diameter was about 80 --

COLUMN 57:
Line 12, "depositions":" should read --deposition";--.

COLUMN 59:
Line 16, "weak," should read --week,--.

COLUMN 63:
Table C-9, "haTLhing" should read --hatching--.
Line 59, "come" should read --become--.

COLUMN 74:
Line 2, "taken once" should read --first taken--.

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COLUMN 78:
Line 65, "were" should read --was--.

COLUMN 79:
Table D-3:

" Example
Ra of first layer surface:
D-1 D-3
3 nm 15 nm 19 nm 15 nm 29 nm"

should read
-- Example

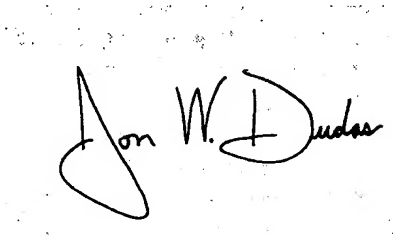
	D-1	D-3
Ra of first layer surface:	3 nm 15 nm 19 nm	25 nm 29 nm--.

COLUMN 80:
Line 21, "was" should read --were--.

COLUMN 81:
Line 48, "was" should read --were--.
Line 57, "after" should read --after being--.

Signed and Sealed this

Twenty-first Day of November, 2006



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